



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79054

Masashi OTSUKI, et al.

Appln. No.: 10/758,130

Group Art Unit: 1754

Confirmation No.: 5017

Examiner: Ngoc Yen M. Nguyen

Filed: January 16, 2004

For: SILICON CARBIDE POWDER AND METHOD FOR PRODUCING THE SAME

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for the third month's extension of time, extending the time for responding to the Office Action of June 3, 2005, to December 5, 2005 (December 3, 2005, falling on a Saturday). A Petition for the first and second month's Extension of time was submitted on November 3, 2005.

A check for the statutory fee of \$570.00.00 is attached (payment of the statutory fee of \$450.00 for the first and second months' extension of time was made on November 3, 2005). The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: December 5, 2005

Respectfully submitted,

Fang Liu  
Registration No. 51,283